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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Akinobu Sato, et al.

Serial No.: 10/573,942

Examiner: Rodney Glenn McDonald

Filing Date: March 29, 2006

Art Unit: 1753

Title: Solid surface smoothing  
method and apparatus therefor

Conf. No. 5411

September 11, 2007  
San Francisco, California

Mail Stop Amendment  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Pursuant to the duty of disclosure set forth in 37 CFR § 1.56, Applicants respectfully submit the following information disclosure statement.

The undersigned certifies that each of the following references was contained in a communication from the EPO in a counterpart foreign application not more than three months prior to the filing of this statement.

The disclosed references are:

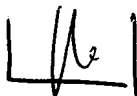
PCT Application Publication No. WO 03/048407, Epion Corp., dated 6-12-2003.

PCT Application Publication No. WO 01/41181, Epion Corp., dated 6-7-2001.

Yamada, I., et al.; "Materials processing by gas cluster ion beams," Materials Science & Engineering Reports, Elsevier Sequoia, S.A., Lausanne, CH, Vol. 34, no. 6, Oct. 30-01, pp. 231-295.

Applicants respectfully request that the Examiner initial the cited references shown on the enclosed form PTO-1449 and that the references be made of record in the present application.

Respectfully submitted,

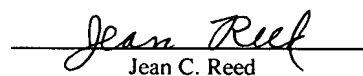


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Enc. PTO Form 1449  
Cited references (3)  
Return receipt postcard

**Certificate of Mailing Under 37 CFR 1.8**

I certify that this Information Disclosure Statement and all enclosed materials are being deposited with the United States Postal Service on September 11, 2007 with sufficient postage as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Jean C. Reed

Substitute Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEDOCKET  
NAA237S.N.  
10/573,942

## INFORMATION DISCLOSURE STATEMENT

APPLICANT  
Akinobu Sato, et al.FILING DATE  
March 29, 2006GROUP  
1753

## U.S. PATENT DOCUMENTS

Cite Initial No.	DOCUMENT NUMBER Number - Kind Code	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	FILING DATE
	US-			
	US-			
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## FOREIGN PATENT DOCUMENTS

*Exam. Initial	Cite No.	DOCUMENT NUMBER Number - Kind Code	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	TRANSLATION YES NO	
		WO 03/048407	6-12-2003	PCT, Epion Corp.		
		WO 1/41181	6-7-2001	PCT, Epion Corp.		

## NON-PATENT LITERATURE DOCUMENTS

*Exam. Initial	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	TRANSLATION YES NO	
		Yamada, I., et al.; "Materials processing by gas cluster ion beams," Materials Science & Engineering Reports, Elsevier Sequoia, S.A., Lausanne, CH, Vol. 34, no. 6, Oct. 30-01, pp. 231-295.		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP; draw line through citation if not in conformance and not considered. Include copy of this form with next communication with applicant.